EAGLEi[™] 200 Automated Wafer Carrier Inspection System



The EAGLEi 200 is an all new non-contact measurement system designed specifically for wafer cassette inspection, accurate to ± 0.001 inches.

Features

- Automatically verify critical wafer carrier dimensions
- Flexibility to run 2" to 200 mm cassettes, Quartz, and SiC Boats
- 6 sigma repeatable measurements
- Certificate of Compliance report generator
- Fast & easy to operate
- Non-contact measurements
- NEW System with 1 Year Warranty

Benefits

- Increase yields using only in-tolerance carriers
- Quickly identify problem carriers
- Reduce carrier-related downtime
- Improve carrier interoperability
- Carrier size flexibility





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FEATURES

Accuracy

±0.001 inches [±0.025 mm]

Repeatability

±0.0005 inches [±0.013 mm] 6 Sigma, using standard calibration tool provided with system.

Speed

Based on the number of user defined measurements (typical inspection time is 45-60 sec.).

Carrier Size

2" to 200 mm Cassettes

Carrier Type

Any carrier manufacturer, and any color material, including clear. With optional adapter plate, quartz and SiC boats measurements are also possible (limited measurement).

Calibration

Automated calibration using standard calibration tool. Included with system and traceable to N.I.S.T. standard

User Interface

Microsoft Windows[®] 10, color flat panel screen and trackball. Password protection allows user to customize system access.

Data Collection

A pass/fail decision is displayed after each inspection cycle. Measurement data can be stored to hard drive, USB drive, printed to a variety of printers, sent over RS232 in metric or English units. Measurement data can also be exported to Excel[®] or other statistical software as ".txt" files.

Cleanroom Compatibility

Class 10 cleanroom compatible (with appropriate installation).

Requirements

- 100-240 VAC, 50-60 Hz Operating Temperature: 68°-72°F [20°-22° C]
- Environmental Vibration (max.): - 2.0 µm Peak-to-Peak (<7Hz) - 0.5 µm Peak-to-Peak (7-150Hz)
- 1.0 µm Peak-to-Peak (>150Hz)
- Annual Preventive Maintenance Service

Options

- Adapter Platforms for measuring quartz boats, SiC boats, or other parts.
- Bar-code Reader (handheld) for automatic carrier ID and data tracking.
- Warranty/Service Contracts for expanded system support.

VERIFY CRITICAL CARRIER DIMENSIONS

The EAGLEi 200 is designed specifically for the semiconductor industry to automatically verify critical wafer carrier dimensions. Fabs use the EAGLEi 200 to quickly identify out-oftolerance carriers through in-coming and in-process inspection. Removing carriers that do not meet specification will improve wafer transfers, maximize equipment availability, and enhance overall yield through a reduction in wafer breakage and particle contamination. Key EAGLEi 200 features include:

- High accuracy and repeatability
- Fast/non-contact inspection
- Simple operation including auto-focus and illumination
- Auto-Train
- Auto-WalkThrough
- Automatic data collection and reporting





During inspection, the EAGLEi 200 precisely lowers the carrier into the system enclosure. Mounted inside the enclosure are high resolution CCD cameras and computer controlled LED illumination that quickly scan the carrier and capture images of key features for measurement.





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STANDARD MEASUREMENTS

Working closely with the world's leading carrier manufacturers, the EAGLEi 200 has been designed to perform the most critical SEMI standard measurements. Other measurements may be defined by the user.





Hiah-resolution CCD camera image used for measurements